

**RECORDATION FOR
PATENTS**

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DEPARTMENT OF COMMERCE

(REV. 6-93)

OMB No. 071651-0011 (exp. 4/94)



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To the Honorable Commissioner of Patents and Trademarks: Please record the attached original documents or copy thereof.

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Erez N. Ribak

Additional name(s) of conveying party(ies) attached?

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4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution
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A. Patent Application No.(s)

B. Patent No.(s)

09/613,759 filed 11 July 2000

Additional numbers attached? ☐ Yes ☒ No5. Name and address of party to whom correspondence
concerning document should be mailed:Name: SOL SHEINBEINInternal Address: c/o ANTHONY CASTORINA
SUITE 207Street Address: 2001 JEFFERSON DAVIS HWY.City: ARLINGTON State: VIRGINIA ZIP: 222026. Total number of applications and
patents involved: 1

7. Total fee (37 CFR 3.41).....\$ 40

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Sol Sheinbein

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ASSIGNMENT

For good and valuable consideration, the receipt and sufficiency of which is hereby acknowledged, the undersigned:

EREZ N. RIBAK
8 MISHMAR HAGVOUL, 34566 HAIFA, ISRAEL

(hereinafter called the "assignor(s)"), hereby sell(s), assign(s) and transfer(s) to:

TECHNION RESEARCH AND DEVELOPMENT FOUNDATION LTD.
TECHNION CITY, 32000 HAIFA, ISRAEL

(hereinafter called the "assignee(s)"), its/his successors, assignees, nominees or other legal representatives, the Assignor's entire right, title and interest in and to the invention entitled:

VOLTAGE AND LIGHT INDUCED STRAINS IN POROUS CRYSTALLINE MATERIALS AND USES THEREOF

described and claimed in the following patent applications:

U.S. Patent Application identified as Attorney docket No.: 00/20096 and executed the same date as this assignment;

and in and to said Patent Applications, and all original and reissued Patents granted therefor, and all divisions and continuations thereof, including the right to apply and obtain Patents in all other countries, the priority rights under International Conventions, and the Letters Patent which may be granted thereon;

Signed and sealed this 9th day of July 2000


EREZ N. RIBAK